

U.S. Department of Commerce, Patent and Trademark Office						Attorney Docket No.		Serial No.	
						DC-03112		10/688,237	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT						Applicant(s)			
(Use several sheets if necessary)						Munif Farhan Halloush, et al.			
						Filing Date		Group	
						October 18, 2003		2655	
U.S. Patent Documents									
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
	AA	2003/0021201 A1	Jan. 30, 2003	Kobayashi	369	47.39			
	AB	2003/0058765 A1	Mar. 27, 2003	Schreurs et al.	369	47.53			
	AC								
	AD								
	AE								
	AF								
	AG								
	AH								
	AI								
	AJ								
	AK								
Foreign Patent Documents									
							Translation		
		Document	Date	Country	Class	Subclass	Yes	No	
	AL	KR2003069706	Aug. 27, 2003	Republic of Korea	G11B	7/004	<input type="checkbox"/>	<input type="checkbox"/>	
	AM	KR2002096641	Dec. 31, 2002	Republic of Korea	G11B7	7/125	<input type="checkbox"/>	<input type="checkbox"/>	
	AN						<input type="checkbox"/>	<input type="checkbox"/>	
	AO								
	AP								
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)									
	AR	Ohkubo, S. et al. "Optimization of Write Strategy in a PRML System for High Density Recording" International Symposium on Optical Memory and Optical Data Storage Topical Meeting, July 7-11, 2002, Pages 425-427							
	AS								
	AT								
Examiner			Date Considered						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.									